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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Toshiaki KAKEMURA et al.

Group Art Unit: 1715

Serial No: 10/529,362

Examiner: Elizabeth A. Burkhart

Confirmation No.: 4778

Filed: March 28, 2005

For: THIN FILM FORMING METHOD, THIN FILM FORMING DEVICE, AND THIN FILM FORMING PROCESS MONITORING METHOD

AMENDMENT WITH RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is responsive to the final Office Action mailed September 8, 2010, having a shortened period for response set to expire on December 8, 2010. The following amendments and remarks are respectfully submitted in conjunction with a Request for Continued Examination (RCE).